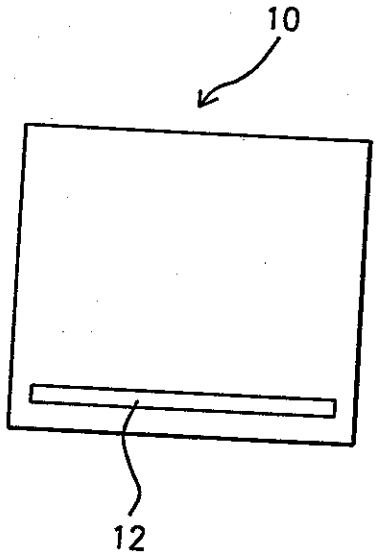


FIG. 1

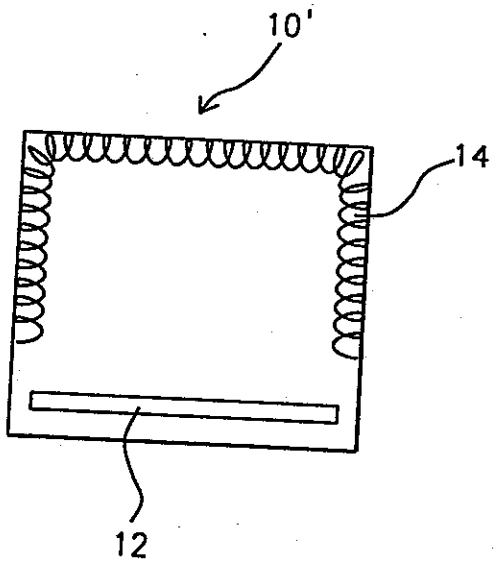


FIG. 2

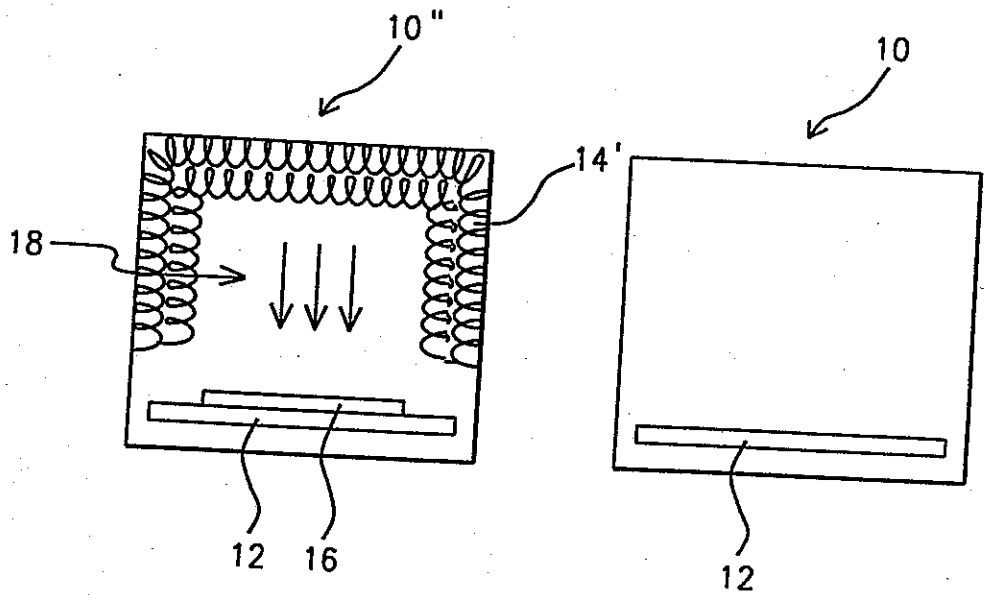


FIG. 3

FIG 4

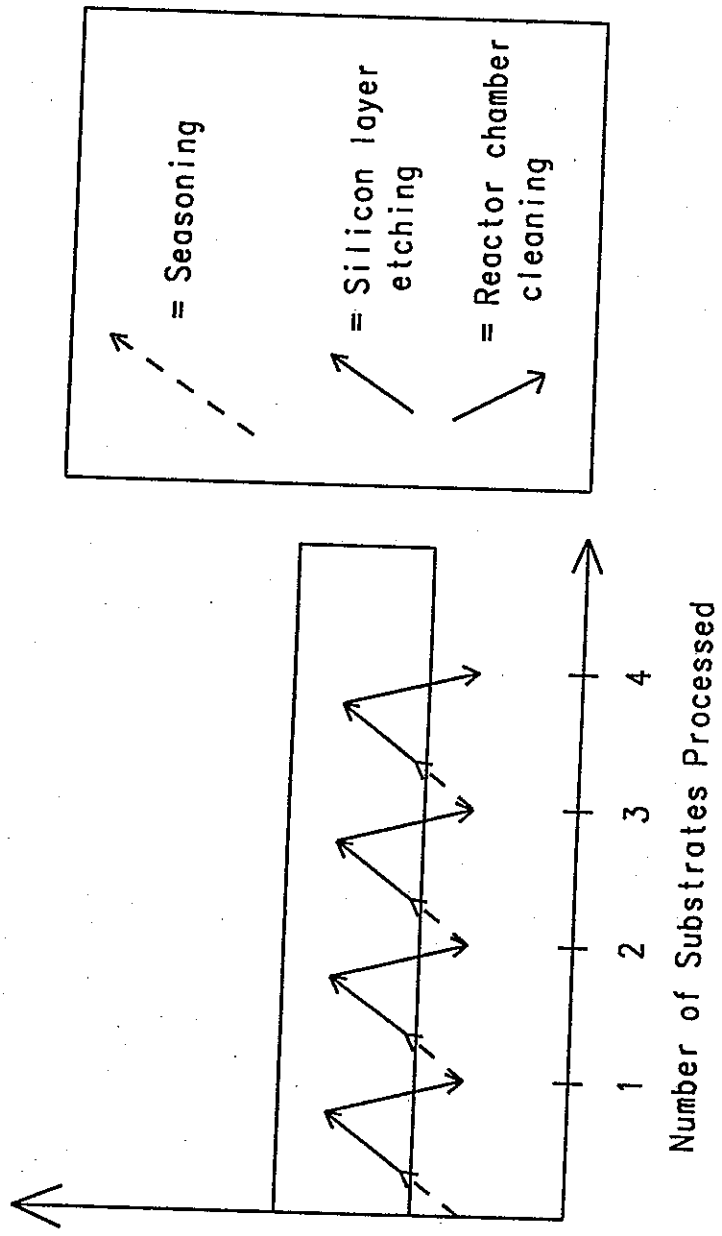

= Seasoning
= Silicon layer etching
= Reactor chamber cleaning
Plasm Reactor Chamber Seasoning Polymer Content (Relative)
1
2
3
4
Number of Substrates Processed

FIG. 5